



VIRTUAL TRAINING COURSE, 27 October 2020

METROLOGY FOR MEASUREMENT OF NANOPARTICLE SIZE BY ELECTRON MICROSCOPY & ATOMIC FORCE MICROSCOPY



Dutch
Metrology
Institute

To join this free virtual training course please send the registration form before 23 October to:

Marion de Niet (mdniet@vsl.nl)

so we can invite you to participate.

Agenda

27 October 2020, afternoon

| Time (CET) | Activity |
|---------------|--|
| 13:00 - 13:05 | Opening – R. Koops (VSL) |
| 13:05 - 13:20 | The EMPIR project nPSize – D. Hodoroaba (BAM) |
| 13:20 - 13:45 | Metrology of SEM measurements of nanoparticles – L. Crouzier (LNE) |
| 13:45 - 14:10 | Metrology of TSEM measurements of nanoparticles – T. Klein (PTB) |
| 14:10 - 14:35 | Metrology of AFM measurements of nanoparticles – R. Koops (VSL) |
| 14:35 - 14:50 | Sample preparation – C. Hörenz (BAM) |
| 14:50 - 15:15 | Break |
| 15:15 - 15:35 | Hybrid methods for microscopy of nanoparticles (SEM/TSEM/AFM) – N. Feltin, D. Hodoroaba et al. (LNE/BAM/SMD) |
| 15:35 - 16:00 | Machine learning in Nanoparticle Metrology – Julien Baderot (POLLEN) |
| 16:00 - 16:20 | VAMAS RRT for Shape and Size Analysis of Nano-particles by Atomic Force Microscopy – Dr. Daisuke Fujita (NIMS) |
| 16:20 - 16:40 | OECD projects on nanoparticle characterisation – A. Schmidt (BAM) |
| 16:40 - 17:00 | In-situ nano particle metrology using traceable flow cytometry – A. van de Nes (VSL) |
| 17:00 - 17:05 | Closing statements – R. Koops (VSL) |